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Study of the spectral and power characteristics of $\text{In}_{0.2}\text{Ga}_{0.8}\text{N}/\text{GaN}$ superluminescent light emitting diodes by taking into account the piezoelectric polarization fields

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Abstract

In this study, the effects of the piezoelectric polarization field have been investigated on the spectral and power characteristics of $\text{In}_{0.2}\text{Ga}_{0.8}\text{N}/\text{GaN}$ superluminescent light emitting diodes. The Schrödinger and Poisson equations, the rate equations in the multiple quantum well active region and separate confinement heterostructure layers, and the optical propagating equations have been solved in the presence of the piezoelectric field. The results have been compared with results of the case of without piezoelectric field. According to the results, in the presence of piezoelectric field, the red-shift occurs in the spectra, and the width of spectrum increases. Also, the piezoelectric field decreases the peak intensity of spectrum and modal gain of the device.

Keywords superluminescent light emitting diodes . internal electric fields . piezoelectric field . spectral and power characteristics . rate equations

1 Introduction

The suitable design of the electronic devices based on InGaN/GaN heterojunctions requires an accurate investigation of the effects of polarization on the quantum well (QW) structures. The performance of devices based on InGaN/GaN can be improved by increasing the information on internal electric fields. The piezoelectric (PZ) polarization is proportional to the strain induced by the lattice mismatch [1]. Furthermore, the spontaneous polarization (SP) is an intrinsic property resulting from the internal cell parameters c/a of the wurtzite materials [2]. In the QW structures, PZ and SP polarizations are the sources of an internal electric field in the range of MVcm^{-1} which causes the so-called quantum confined Stark effect (QCSE) [3]. This field can affect the spectral and the power characteristics of the device [4].

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A superluminescent light emitting diode (SLD) is an edge emitter semiconductor optical source which contains regions of QWs, barriers, separate confinement heterostructure (SCH) and cladding layers. A SLD is based on a p-n junction that operates in amplified spontaneous emission (ASE) regime when it is forward biased. Also the SLD has low optical feedback, and there is no laser performance on it. A SLD combines the low temporal coherence of light emitting diodes (LEDs) with high spatial coherence of laser diodes (LDs). The key parameters for describing SLDs are output power, optical gain, spectrum bandwidth, coherence length, spectrum modulation, and coherence function. The SLD has been developed as a key element in fiber optic gyroscopes, optical coherence tomography for medical imaging, and fiber-optic communication devices. Other applications include optical fiber sensors, display screens for projectors, optical test instruments, and spectroscopy [5-10].

Most produced SLDs are based on GaAs and InP. In recent years, studies have been conducted on GaN-based SLDs. A high optical power blue-emitting SLD grown on semi-polar bulk GaN substrate was described by C. Shen et al. [11]. Also, A. Kafar et al. have reported InGaN/GaN superluminescent diodes with broadened emission spectra fabricated on surface-shaped bulk GaN (0001) substrates [12]. M. T. Hardy et al. have conducted theoretical studies on the GaN based SLDs [13]. K. Holc et al. have examined the temperature dependence of InGaN-based SLD structures [14]. N. M. Milani et al. have presented a new theoretical model for broadband blue InGaN/GaN SLDs [15]. However, the effects of polarization fields on the output of SLDs have not been considered in any of these studies. Given the importance of polarization in nitride materials, the effect of polarization on SLDs must be taken into account. In this article, we examine the effects of the polarization on the spectral and power characteristics of In_{0.2}Ga_{0.8}N/GaN multiple quantum well (MQW) blue SLD via a self-consistent solution of the Schrödinger and Poisson equations, the rate equations in MQW active region and SCH layers, and the optical propagating equations.

2 Theory

The polarization in the SLD has the excellent effect on the recombination of carriers. Therefore it is important to have a precise description of the polarization. The PZ coefficients of In_xGa_{1-x}N vary linearly with indium mole fraction [16]. In In_xGa_{1-x}N/GaN structure, which is under the influence of biaxial compressive strain, the PZ polarization is in the (0001) direction, therefore the SP and PZ polarizations opposes each other [17]. In this structure, the PZ field is much bigger than the SP polarization, so the total internal field value is close to that of the PZ field. If a material is grown as pseudomorphically on a substrate with different lattice constant, the grown layer is related to PZ polarization. The PZ polarization in the grown layer is expressed as follows [1]

$$P_{PZ} = 2\varepsilon_{xx} \left(e_{31} - e_{33} \frac{c_{13}}{c_{33}} \right) \quad (1)$$

where ε_{xx} is the basal strain that defined as,

$$\varepsilon_{xx} = \frac{a_{GaN} - a_{InGaN}}{a_{InGaN}} \quad (2)$$

where a_{GaN} is the lattice constant of substrate, and a_{InGaN} is the lattice constant of grown layer. The PZ field is expressed as follows

$$F = -\frac{P_{PZ}}{\kappa\varepsilon_0} \quad (3)$$

where κ and ε_0 are the dielectric constant of the semiconductor and vacuum permittivity, respectively. The material parameters of $In_{0.2}Ga_{0.8}N$ are listed in Table 1.

Table 1 Material parameters of $In_{0.2}Ga_{0.8}N$

Parameter	Symbol	Unit	Value	Refs.
Lattice constant at 300K	a_{InGaN}	\AA	3.26	18,19
Static dielectric constant	κ	ε_0	11.06	19
Band gap energy at 300K	E_g	eV	3.19	18
Elastic stiffness constant	c_{11}	GPa	356.6	20
Elastic stiffness constant	c_{12}	GPa	139.0	21
Elastic stiffness constant	c_{13}	GPa	103.2	22
Elastic stiffness constant	c_{33}	GPa	210.4	22
Piezoelectric constant	e_{31}	Cm^{-2}	-0.34	23
Piezoelectric constant	e_{33}	Cm^{-2}	0.54	19,23
Spontaneous polarization	P^{SP}	Cm^{-2}	-0.041	18
Hydrostatic deformation potential	D	eV	-6.76	24

In order to design an appropriate SLD, it is necessary to have information about the band structure of the active region as well as the effects of the internal electric field on it. This is done by solving the Schrödinger and Poisson equations separately for conduction and valence bands based on effective mass approximation under an electric field. The polarization can alter the optical and electrical characteristics of the structure. Hence, it should also be taken into account when solving the Schrödinger and Poisson equations. We must calculate the subband energies of the QWs in active region. In our study, this is done by the Finite Difference Method (FDM). A schematic of the SLD structure is shown in Fig. 1. In SLD, the QWs produce the light, while the SCH and cladding layers play the role of confinement and waveguides of the light, respectively [25].

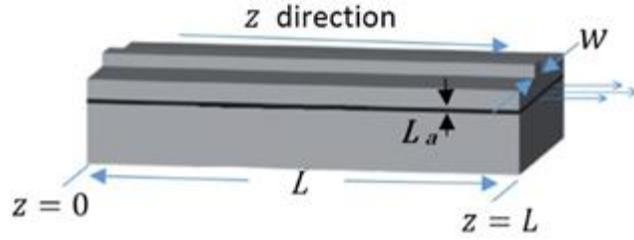


Fig. 1 Schematic of the SLD structure.

Fig. 2 shows the profile of the studied MQW structure in without PZ field (green dashed lines) and with PZ field (blue lines) cases. This structure consists of four $\text{In}_{0.2}\text{Ga}_{0.8}\text{N}$ QWs (3 nm thickness) separated by three GaN barrier layers (10 nm thickness). The two AlGaN SCH layers (100 nm thickness) are located on the up and down of the active region. The temperature of active region is supposed constant (300K). The conduction and valence bands of MQW are strongly influenced by the PZ field. The PZ field can change the lineup of conduction and valence bands. Therefore, the depth of the well in the conduction and valence bands increases and decreases, respectively [26]. Also, the PZ field can tilt the structure of the bands. In this case, the structure of the well becomes to a triangular well.

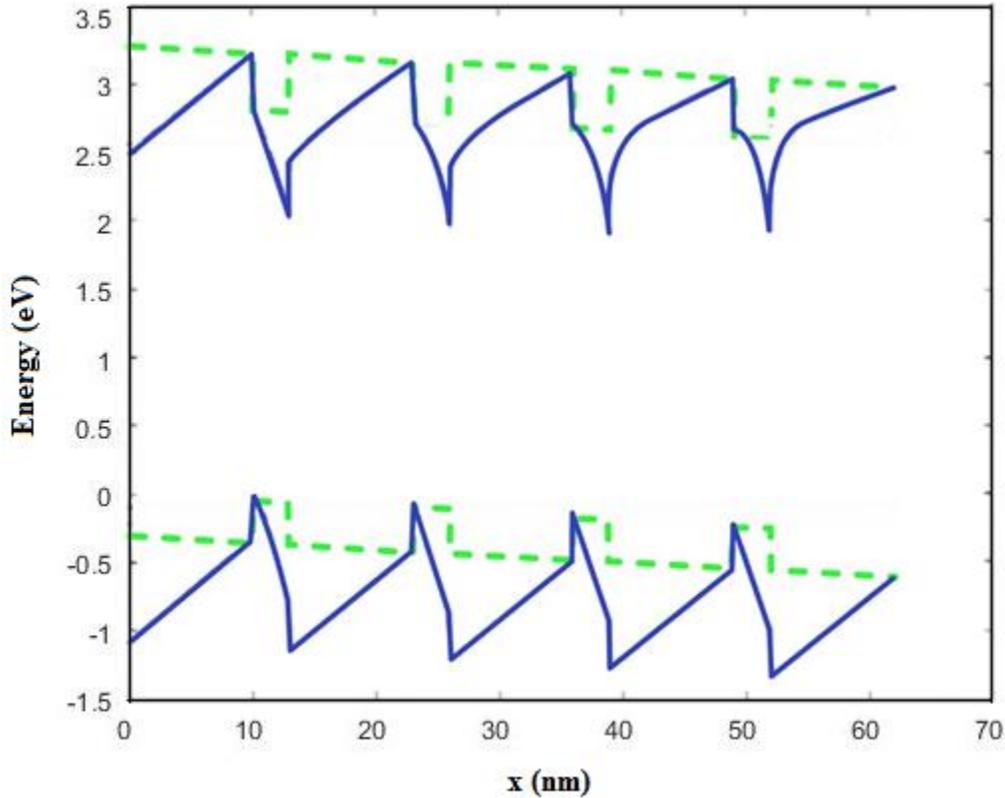


Fig. 2 Profile of the studied structure in without PZ field (green dashed lines) and with PZ field (blue lines) cases.

In our theoretical model, the rate equations are written by taking into account the effects of carriers escape from MQW to the SCH layer and the transport of carriers from SCH layer to MQW. The optical propagating equations are also written according to spectral power densities, i.e. $P_{\pm}(z, \lambda)$. We assume that the injection current is applied from the cladding layer to the SCH layer. Therefore, regardless the leakage effect from SCH layer, the equations are

$$\frac{dN_{SCH}}{dt} = \frac{1}{e} \frac{J}{L_{SCH}} - \frac{N_{SCH}}{\tau_s} + \frac{N}{\tau_e} \frac{L_{QW}}{L_{SCH}} - \frac{N_{SCH}}{\tau_{n(SCH)}} \quad (4)$$

$$\frac{dN}{dt} = \frac{N_{SCH}}{\tau_s} \frac{L_{SCH}}{L_{QW}} - N \left[\frac{1}{\tau_e} + \frac{1}{\tau_n} \right] - R_{st} \quad (5)$$

$$\frac{1}{v_g} \frac{\partial P_{\pm}(z, \lambda)}{\partial t} \pm \frac{\partial P_{\pm}(z, \lambda)}{\partial z} = [\Gamma g(\lambda) - \alpha] P_{\pm}(z, \lambda) + \frac{hc}{2\lambda} \beta \Gamma r_{sp}(\lambda) S \quad (6)$$

In above equations, J is the current density, N is the carrier density per unit volume of QWs, and N_{SCH} is the carrier density per unit volume of the SCH layers. τ_n is the carrier recombination lifetime in the QW, $\tau_{n(SCH)}$ is the carrier recombination lifetime in SCH layers, τ_s is the carrier transport time in the SCH layers, and τ_e is the carrier escape time from the well to SCH layer. The relation of τ_s is $\tau_s = \tau_d + \tau_c$, where τ_d and τ_c are diffusion time and capture time, respectively. For MQW active region they are defined as:

$$\tau_c = \Gamma_q \tau_c^{SQW} \quad (7)$$

$$\tau_d = \frac{eL_{SCH}^2}{2kT\mu_n} \quad (8)$$

$$\tau_e = \frac{\tau_e^{SQW}}{\Gamma_q} \quad (9)$$

where Γ_q is the fraction of the MQW region filled by the QWs. Symbol SQW denotes single QW and μ_n is electron mobility [27-29]. $r_{sp}(\lambda)$ is the spontaneous emission rate of photons [15,30]:

$$r_{sp}(\lambda) = \frac{8\pi n_r^2}{h\lambda^2} n_{sp} g(\lambda) \quad (10)$$

$$n_{sp} = \left[1 - \exp\left(\frac{hc\lambda^{-1} - (F_C - F_V)}{kT} \right) \right]^{-1} \quad (11)$$

where F_C and F_V are quasi-Fermi levels in the conduction and valence bands, respectively. R_{st} is the stimulated recombination of carriers [15,30]:

$$R_{st} = \int \Gamma \lambda g(\lambda) \frac{P_{(z,\lambda)}^+ + P_{(z,\lambda)}^-}{hcS} d(\lambda) \quad (12)$$

and S is the cross section of active region of SLD that defined as multiplication of the thickness and width of the active region. Other parameters are listed in Table 2. The parameters without reference have been calculated for this research and general parameters are available in Ref. [15].

The carrier reduction rates, due to the radiative and non-radiative recombination, are $\tau_n^{-1} = A + BN + CN^2$ and $\tau_{n(SCH)}^{-1} = A_{SCH} + B_{SCH}N_{SCH} + C_{SCH}N_{SCH}^2$, respectively, where $A, B, C, A_{SCH}, B_{SCH}$, and C_{SCH} are the Shockley-Read-Hall, spontaneous radiative recombination, and Auger recombination coefficients in QW and SCH layers, respectively [31,32]. We have used the gain in the model of transitions without the k-selection rule because it is better compatible with SLDs [33], therefore by considering this model, the spectral gain as a function of wavelength is expressed by [15]

$$g(\lambda) = GLn\left[\frac{1 + \exp\left[\frac{\lambda(F_C - E_{hl}) - hc}{\lambda kT}\right]}{1 + \exp\left[\frac{(F_C - E_{el})}{kT}\right]}\right] \times \frac{1 + \exp\left[\frac{\lambda(F_V - E_{el}) + hc}{\lambda kT}\right]}{1 + \exp\left[\frac{(F_V - E_{hl})}{kT}\right]} \quad (13)$$

where

$$G = -\frac{2\lambda e^2 m_{ew}^* m_{hw}^* a_0^2 kT}{m_0^2 \varepsilon_0 n_r c^2 \hbar^4 \pi L_{QW}} |M|^2 \quad (14)$$

and n_r is the refractive index of QW. E_{hl} and E_{el} are the first energy subbands for heavy holes and electrons in QW, respectively. In presence of the PZ field, these values are changed, and therefore the value of gain is changed. m_{hw}^* and m_{ew}^* are the effective mass of heavy holes in the QW valence band and effective mass of electrons in QW conduction band, respectively [30]. The momentum matrix elements $|M|^2$ represent the stimulated electron transitions that depend on the angle between the electron wave vector and the optical field vector. The momentum matrix elements are anisotropic, and the gain depends on the optical polarization. Usually, there are two distinct polarization modes, in which either the electric field (TE mode) or the magnetic field (TM mode) lies within the QW transversal plane (x-y plane) [36-38].

The electric field caused by PZ polarization affects the overlap integral and reduces it. In TE mode, the momentum matrix elements are written as, [15]

$$(M_{TE}^b)^2 = \frac{3}{2} O_{ij} \left[\frac{m_0}{6} \left(\frac{m_0}{m_{ew}^*} - 1 \right) \frac{E_g^s [(E_g^s + \Delta_1 + \Delta_2)(E_g^s + 2\Delta_2) - 2\Delta_3^2]}{(E_g^s + \Delta_1 + \Delta_2)(E_g^s + \Delta_2) - \Delta_3^2} \right] \quad (15)$$

where O_{ij} is the overlap integral, and m_{ew}^* is the electron effective mass in transversal direction relative to the hexagonal c-axis. The Δ_1, Δ_2 and Δ_3 parameters represent the diagonal and non-diagonal elements of 6×6 Hamiltonian that explain the three valance bands [35]. The strain changes the band gap energy. In this case, the band gap energy is [24]:

$$E_g^s(x) = E_g(x) + 2D \left(1 - \frac{c_{12}}{c_{11}} \right) \varepsilon_{xx} \quad (16)$$

where D is the interband hydrostatic deformation potential, and c_{11} and c_{12} are the elastic stiffness constants. Our self-consistent calculations have been carried out in both strained and unstrained cases for comparison.

Table 2 Physical constants and calculated parameters used in this study

Parameter	Symbol	Unit	Value	Refs.
Cavity length	L	μm	800	
Thickness of QW	L_{QW}	nm	3	
Thickness of SCH layers	L_{SCH}	nm	100	
Thickness of active region	$L_a = 4L_{QW}$	nm	12	
Width of active region	w	μm	2	
Bohr effective radius	a_0	nm	0.5228	
Lattice constant of GaN	a_{GaN}	\AA	3.189	18
Internal loss coefficient	α	cm^{-1}	37	34
MQW confinement factor	Γ		0.017	15
Spontaneous coupling coefficient	β		0.05	15
Vacuum permittivity	ϵ_0	Fm^{-1}	8.85×10^{12}	
Refractive index of QW	n_r		3.34	
Electron effective mass in transversal direction relative to c-axis in QW	m_{ew}^{*t}	m_0	0.18	
Effective mass of heavy hole in the QW valence band	m_{hw}^*	m_0	0.75	
Shockley-Read-Hall coefficient in QW	A	s^{-1}	1×10^7	31
Spontaneous radiative recombination coefficient in QW	B	$Cm^3 s^{-1}$	2.0×10^{-11}	31
Auger recombination coefficient in QW	C	$Cm^6 s^{-1}$	1.5×10^{-30}	32
Shockley-Read-Hall coefficient in SCH	A_{SCH}	s^{-1}	1.2×10^9	31
Spontaneous radiative recombination coefficient in SCH	B_{SCH}	$Cm^3 s^{-1}$	2.4×10^{-11}	34
Auger recombination coefficient in SCH	C_{SCH}	$Cm^6 s^{-1}$	1.4×10^{-31}	32
Escape time in MQW	τ_e	ps	429.47	
Escape time in single QW	τ_e^{SQW}	ps	122.7	
Transport time in SCH	τ_s	ps	1.5736	
Capture time in single QW	τ_c^{SQW}	ps	0.7	
Filling fraction factor in MQW	Γ_q		0.2857	
Crystal-field split energy	$\Delta_1 = \Delta_{cr}$	eV	0.0121	35
One-third of spin-orbit split-off energy	$\Delta_2 = \Delta_3 = \Delta_{so} / 3$	eV	0.005	35

In steady state case, by analyzing the equation (6) and assuming $\exp[\Gamma g(\lambda) - \alpha]L \gg 1$, the total output power of the SLD in a given current on the right facet of the SLD cavity ($z = L$) in direct propagation is defined as

$$P_{out} = \int \frac{4\pi\beta S n_r^2 h c^2 n_{sp}}{\lambda^5} \frac{\Gamma g(\lambda)}{\Gamma g(\lambda) - \alpha} \exp[\Gamma g(\lambda) - \alpha] L d\lambda \quad (17)$$

where n_{sp} is the spontaneous emission factor [15].

By assuming that the z-axis is along the [0001] direction, the Schrödinger equation for electrons and holes is defined as,

$$-\frac{\hbar^2}{2} \frac{\partial}{\partial z} \left[\frac{1}{m_e^*(z)} \frac{\partial \psi_{en}(z)}{\partial z} \right] = [E_{en} - V_C(z)] \psi_{en}(z) \quad (18)$$

$$-\frac{\hbar^2}{2} \frac{\partial}{\partial z} \left[\frac{1}{m_h^*(z)} \frac{\partial \psi_{hm}(z)}{\partial z} \right] = [E_{hm} - V_V(z)] \psi_{hm}(z) \quad (19)$$

where \hbar is the planck's constant divided by 2π , $m_e^*(z)$ and $m_h^*(z)$ are the effective mass of electrons and heavy holes in wells and barriers, respectively, $\psi_{en}(z)$ and $\psi_{hm}(z)$ are the wave function of electrons and heavy holes in in wells and barriers, respectively. We have neglected light holes and split-off holes because gain spectrum for TE polarization (preferred polarization in SLDs [15]) dominated by the heavy hole band [39]. E_{en} and E_{hm} are the subband energy of electrons and heavy holes, respectively, and $V_C(z)$ and $V_V(z)$ are the potential energy in conduction and valance bands, respectively:

$$V_C(z) = \Delta E_C - eFz - e\phi(z) \quad (20)$$

$$V_V(z) = \Delta E_V + eFz + e\phi(z) \quad (21)$$

where ΔE_C and ΔE_V are conduction band gap and valance band gap discontinuity, respectively. The Poisson's equation for the electrostatic potential $\phi(z)$ is expressed as follows

$$\frac{d}{dz} [\kappa \epsilon_0 \frac{d}{dz} \phi(z)] = -e[p(z) - n(z)] \quad (22)$$

where $n(z)$ and $p(z)$ are electrons and heavy holes distribution for first four levels in the wells and barriers [40]:

$$n(z) = \frac{kT m_e^*(z)}{\pi \hbar^2} \sum_{n=1}^4 |\psi_{en}(z)|^2 L n \left[1 + \exp\left(\frac{F_c - E_{en}}{kT}\right) \right] \quad (23)$$

$$p(z) = \frac{kT m_h^*(z)}{\pi \hbar^2} \sum_{m=1}^4 |\psi_{hm}(z)|^2 L n \left[1 + \exp\left(\frac{E_{hm} - F_v}{kT}\right) \right] \quad (24)$$

The process of the simulation method used in this study is presented as flowchart in Fig. 3. As shown, by choosing the minimum current density, and taking into account the initial carrier density and quasi-Fermi Levels equations, the Schrödinger, Poisson and gain equations are solved in the presence of PZ field, and the electronic structure is obtained. Then, the rate equations are solved self-consistently in stationary state. In the case of convergence, the next current density is considered and the program is repeated. Otherwise, the new carrier density is selected and the program is updated. After final current density, the diagrams of the light output power as a function of current, the spectral radiation power as a function of wavelength, and the modal gain as a function of wavelength are plotted.

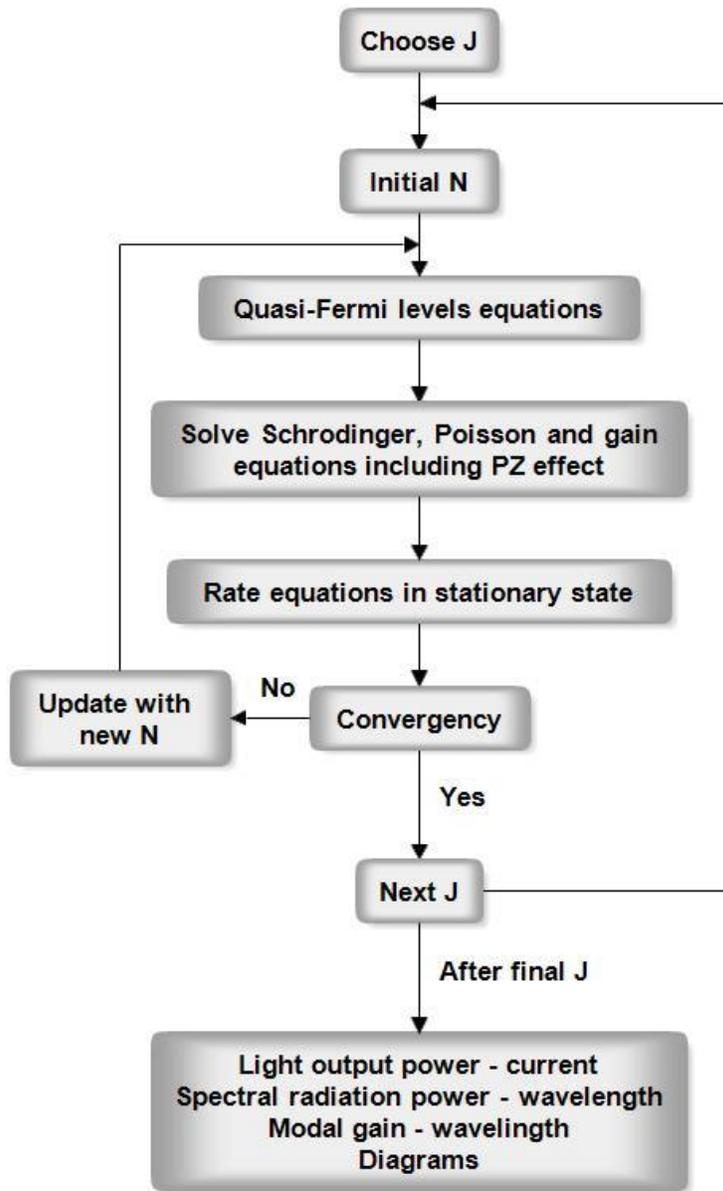


Fig. 3 Flowchart of the process of the simulation method used in this study.

3 Results and discussion

In order to investigate the PZ polarization field effects on the optical properties of the studied device, the light output power as a function of injection current is plotted in Fig. 4 in the cases of with and without PZ polarization. Unlike LDs, the light output power intensity of SLD does not show a sharp threshold, but it gradually rise with increasing of injection current. The soft curvature in the output power curve as a function of the injection current represents the transition from a situation influenced by spontaneous emission (SE) to a situation influenced by ASE. It can be seen from Fig. 4 that with increasing injection current, the output power in both cases (without PZ and with PZ) increases. Comparison of two diagrams shows that in low current injections there are no significant differences in output power of two cases but after that, the output power decreases in the presence of PZ field. The reason for the decline in the output power at high injection currents is that the presence of the PZ field leads to a gradual shrinkage in the spatial overlap between the electron and hole wave functions, where the probability of the radiative recombination diminishes. At applied currents of 110, 270 and 540 mA, the differences between the output power in without PZ and with PZ cases are 0.046, 0.136 and 1.081 mW, respectively. At 600 mA injection current, the maximum powers in without PZ field and with PZ field cases are 13.31 and 11.79 mW, respectively (8.86% dropped power).

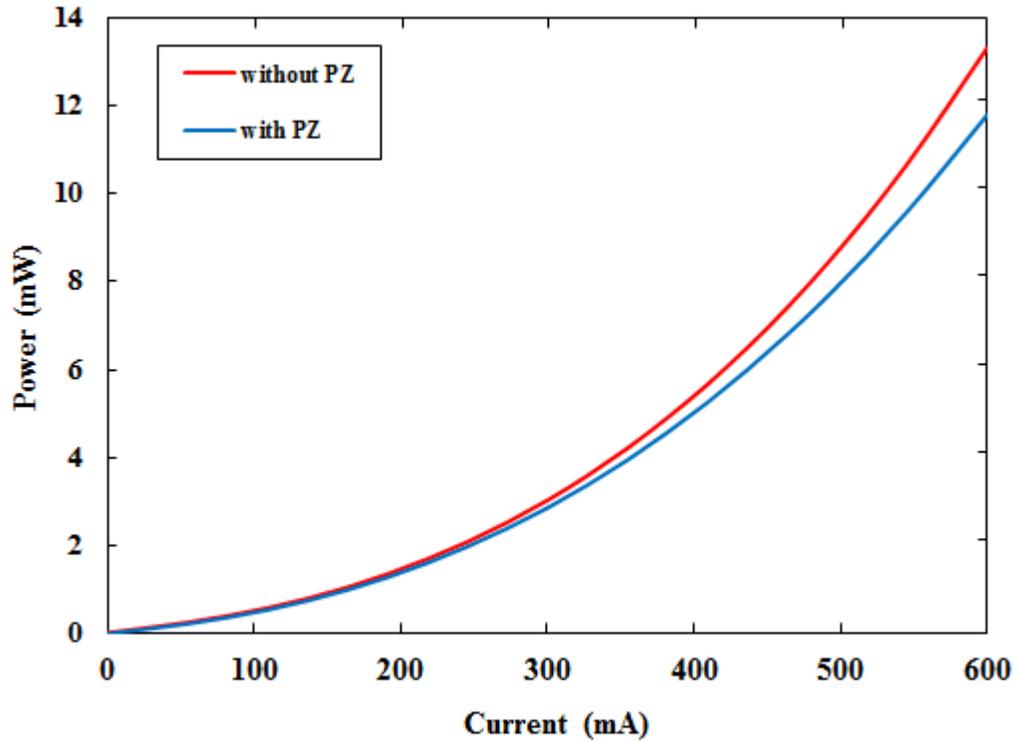


Fig. 4 The light output power as a function of injection current.

Fig. 5 shows the spectral radiation power as a function of wavelength under different injection currents (400, 500 and 600 mA) in without PZ field and with PZ field cases. According to the

diagrams, the obtained spectra are in the form of a Gaussian function. The obtained diagrams are in good agreement with the diagram of the experimental work of Tawfik et al. on the LED [41]. The reason for this comparison is that there is no experimental work in this field on SLDs and therefore comparison is not possible. The peak intensity, the width, and the peak wavelength of spectrum in SLD depend on the composition of the active region and the value of injection current. As seen, upon the rise of the injection current, the electroluminescence (EL) spectra show significant luminescence enhancements because of the photo-electric conversion. As can be seen, in both cases (without PZ and with PZ), with increasing the current, the peaks of the spectrum are transmitted to shorter wavelengths. For example, in with PZ field case, as the injection current increased from 400 to 600 mA, the peak wavelength of the spectra shifted from 425.3 to 424.4 nm. This is mainly due to the screening of internal fields [23]. In ternary nitride alloys grown on GaN, similar to the studied structure, the internal fields significantly affect the properties of QW. Upon augmentation of the injection current into the QW, charge screening is expected to reduce the polarization field effects. This effect has a great influence on the band structure and carrier dynamics in QW. The screening of the electric field inside the QW reduces the polarization effects, with this reduction in QW causing improved efficiency of SLD.

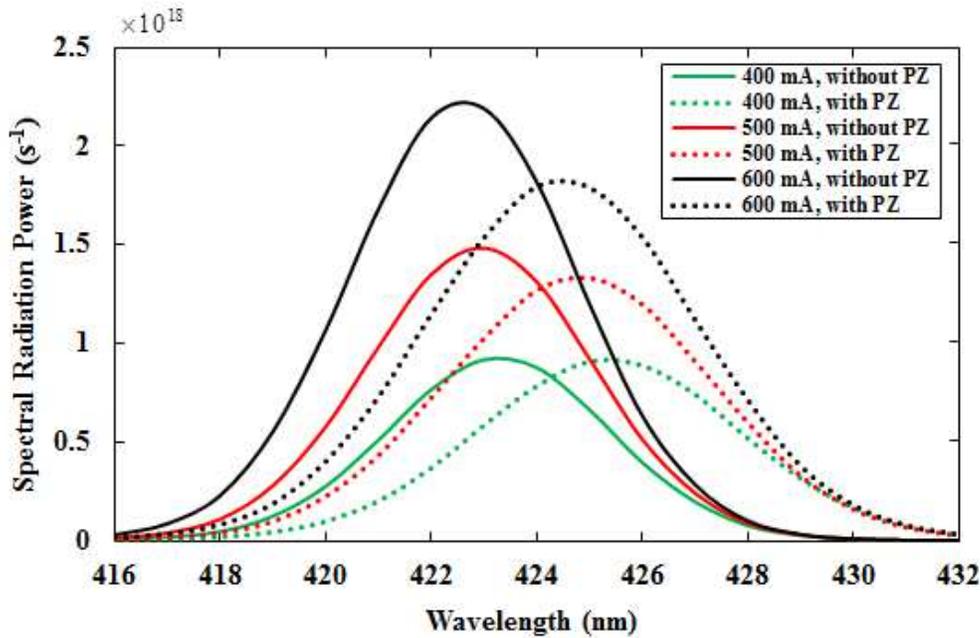


Fig. 5 The spectral radiation power as a function of wavelength under different injection currents in without PZ field and with PZ field cases.

Polarization has an important influence on recombination mechanisms in QWs. The surface polarization charges are somewhat screened by defects of charges, and only about half of them contribute to the internal polarization field [42]. By applying the polarization, the internal field in the p-n junction of the QW is negative, and the holes accumulate at the n-side of junction. In without polarization case, the situation reverses and the holes accumulate on the p-side of the QW.

In both of the above cases, the electron distribution peak is near the center of the QW. At low injection currents, the spectra are affected by the SE process. By increasing the injection current, the ASE process dominates the spectra thus elevating their bandwidth. This can be clearly seen in Fig. 5. On the other hand, it can be observed that in the presence of the PZ field, the spectra shift toward the higher wavelengths. This phenomenon, so-called the red-shift, attributed to the recombination of carriers at the deep energy levels of QW and to the renormalization of the band gap [41,43].

The useful parameters that are related to the distribution of spectral power density at different wavelengths are the optical bandwidth, the peak wavelength, and the peak intensity of the spectrum. The first parameter is the full width at half maximum (FWHM) of spectral power curve versus wavelength, while the second parameter depends on the wavelength with the highest intensity. Table 3 provides the values of the peak wavelength, FWHM, and the peak intensity of the spectra across different injection currents. It can be observed that in both cases (with PZ field and without PZ field), as the injection current rises, the peak wavelength of the spectra is declined. The PZ field reduces the transition energy in QW, and therefore the red-shift occurs in the emission wavelength.

Table 3 The peak wavelength, FWHM, and the peak intensity of the spectra

current (mA)	peak wavelength (nm)		FWHM (nm)		peak intensity (s^{-1}) [$\times 10^{18}$]	
	without PZ	with PZ	without PZ	with PZ	without PZ	with PZ
400	423.3	425.3	4.9	5.9	0.926	0.921
500	422.9	424.7	5.0	5.9	1.484	1.332
600	422.6	424.4	5.1	6.0	2.229	1.828

It can be seen that the PZ field increases the width of the spectrum. The broadening of the spectrum can be attributed to the QCSE and band filling effect [42,44,45]. The band filling effect is due to of the occupation of low energy states of bands by the carriers. Consequently, transitions between the occupied states in the valence and conduction bands are prohibited. It should be noted that a strong PZ field, by tilting the band structure in QW, can reduce the effective width of the well and consequently the carrier capture rate in QW. On the other hand, the PZ field, by reducing the overlap of the electron and hole wave functions, prolongs the lifetime of the carriers in the QW. Hence, the probability of carrier escape rate diminishes, and as a result, the peak intensity of the spectra decreases. At injection current of 400 mA, the peak intensity in without PZ field and with PZ field cases are 0.926×10^{18} and $0.921 \times 10^{18} s^{-1}$, respectively. At 600 mA, these values are 2.229×10^{18} and $1.828 \times 10^{18} s^{-1}$, respectively. It can also be seen that the red-shift occurs in spectra. The results show that in the presence of PZ field, the change in the peak wavelength of the spectra is about 2 nm, which has a good agreement with the results of the Refs. [46] and [47]. At 400 mA, the spectrum peak in cases of with PZ field and without PZ field is in wavelength of 425.3 and 423.3 nm, respectively. At 600 mA, these values are 424.4 and 422.6 nm, respectively.

Fig. 6 shows the FWHM of spectra as a function of injection current in without PZ field and with PZ field cases. In Fig. 5, due to the slight difference in the spectral radiation powers of the

two cases (with and without PZ) at injection currents of 100 to 300 mA, only the currents of 400 to 600 mA are considered. In Fig. 6, in order to better compare the FWHM changes in the two cases, the injection currents of 100 to 300 mA are also considered. As it can be seen from Fig. 6, in the presence of the PZ field, the bandwidth of the spectra increases. The increase of the FWHM of spectra is one of the important features of SLDs. Since the FWHM is dependent on the wavelength and the gain, with increase in the injection current, the gain of device grows, causing enhanced FWHM [11]. In InGaN/GaN MQW structures, the QCSE created by the PZ field separates the electrons and holes spatially. This spreads out the occupancy of the carriers in the joint density of states, whereby the FWHM increases. As previously mentioned, by increasing the injection current, the influence of ASE is intensified, and the spectra are expanded. The maximum value of FWHM in without PZ field obtained in the injection current of 600 mA is 5.1 nm. In the presence of PZ field, as the current injection increases from 100 to 600 mA, the FWHM values rise from 5.6 to 6.0 nm.

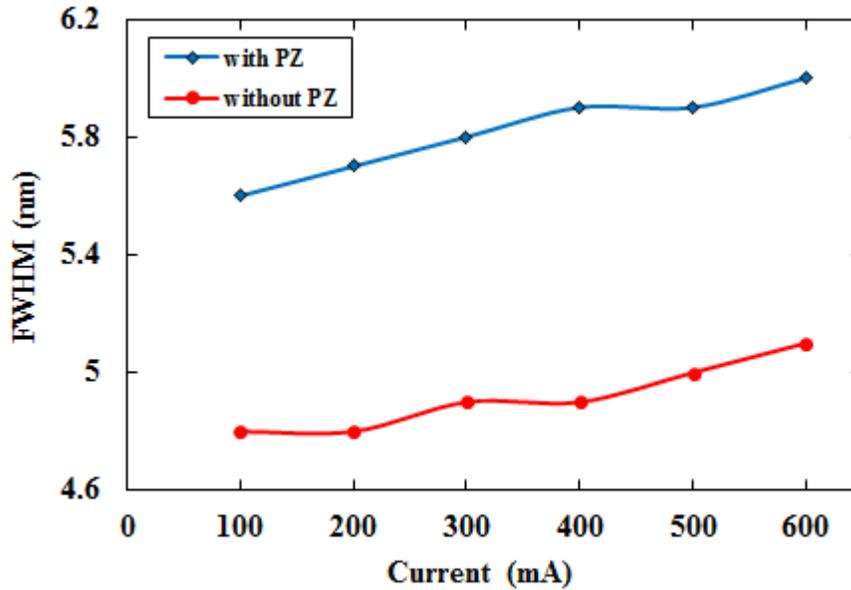


Fig. 6 The FWHM of spectra as a function of injection current in without PZ field and with PZ field cases.

In SLDs, the optical gain is one of the main recombination mechanisms and can be effective on the optical and spectral properties of the structure. Therefore, a careful examination of it is necessary. Fig. 7 shows the modal gain as a function of wavelength in the injection currents of 400, 500 and 600 mA in without PZ field and with PZ field cases. It is observed that in both cases, with increasing the injection current, the modal gain increases. As the carrier density increases in the active region of the device, the distance between the quasi-Fermi surfaces increases, and thus more surfaces can contribute to the optical gain. As a result, the gain increases. On the other hand, it is observed that the PZ field reduces the gain. This is why in SLDs the internal field caused by the PZ polarization causes the spatial separation between the electron-hole wave functions. This

reduces the overlap of electron and hole wave functions and, as a result, the interband optical matrix elements are reduced.

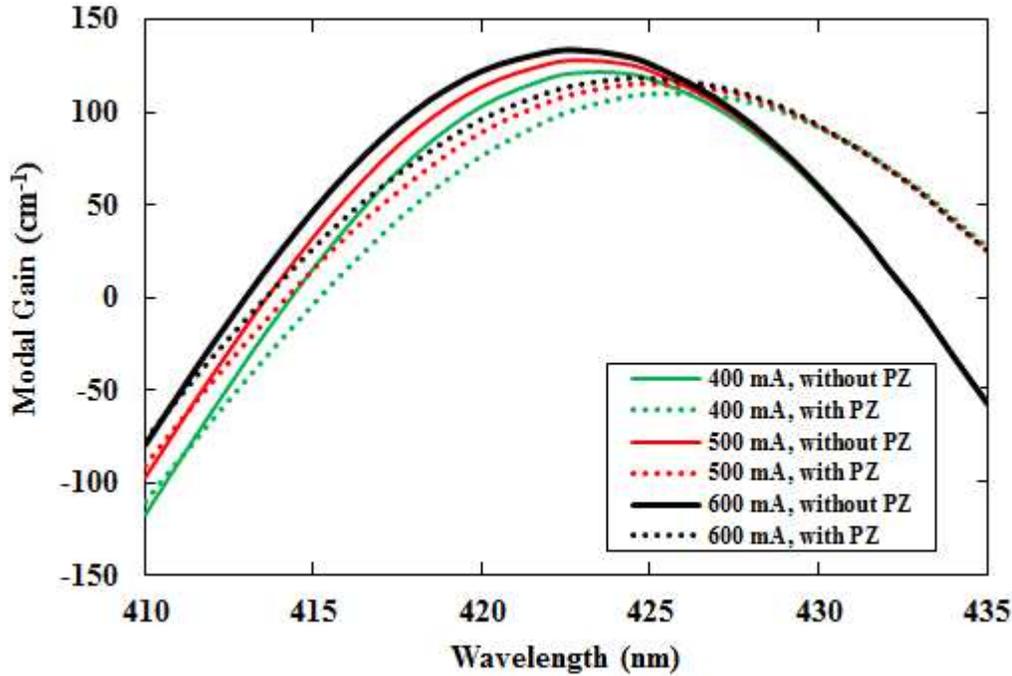


Fig. 7 Modal gain as a function of wavelength at different injection currents in without PZ field and with PZ field cases.

Table 4 presents the peak modal gain values and their corresponding wavelengths at 400, 500 and 600 mA injection currents in without PZ field and with PZ field cases. As can be seen from the table, by increasing the injection current, the peak modal gain increases in both cases. Also, the position of the gain peaks shifts to shorter wavelengths (blue shift). As the carrier density increases, in addition to the band filling effect, the screening electric field also increases. It can be seen that with increasing injection current from 400 to 600 mA, the blue shift of wavelength in without PZ field and with PZ field cases are 1.0 and 1.1 nm, respectively. On the other hand, it is observed that the PZ field reduces the peak modal gain, and increases the wavelength at which the peak modal gain appears (red shift). These redshift values are 2.1, 2 and 2 nm in the 400, 500 and 600 mA injection currents, respectively.

Table 4 The peak modal gain values and corresponding wavelengths

current (mA)	without PZ		with PZ	
	wavelength (nm)	peak modal gain (cm ⁻¹)	wavelength (nm)	peak modal gain (cm ⁻¹)
400	423.5	121.9	425.6	110.7
500	422.9	128.1	424.9	115.1
600	422.5	133.4	424.5	118.9

4 Conclusion

The effects of the strain-induced PZ polarization field investigated on the spectral and power characteristics of In_{0.2}Ga_{0.8}N/GaN SLD. The calculations were based on the self-consistent solution of the Schrödinger and Poisson equations, the rate equations, and the optical propagating equations. The results showed that the presence of the PZ field in the structure led to lose of the modal gain of the device and the peak intensity of spectrum, red-shift in spectra, and increase the FWHM and the peak wavelength of spectra. In presence of PZ field, under 600 mA injection current, the output power has dropped 8.86%. The FWHM was also increased from 5.6 to 6.0 nm.

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Figures

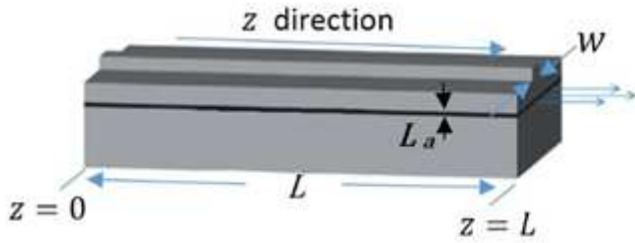


Figure 1

Schematic of the SLD structure.

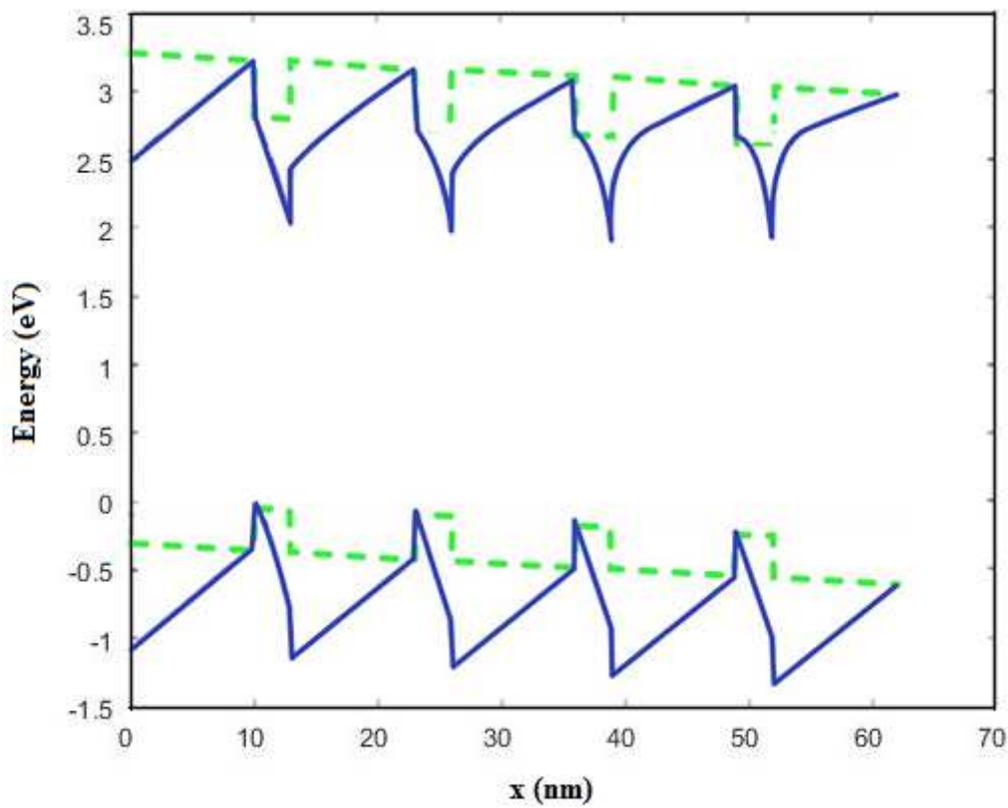


Figure 2

Profile of the studied structure in without PZ field (green dashed lines) and with PZ field (blue lines) cases.

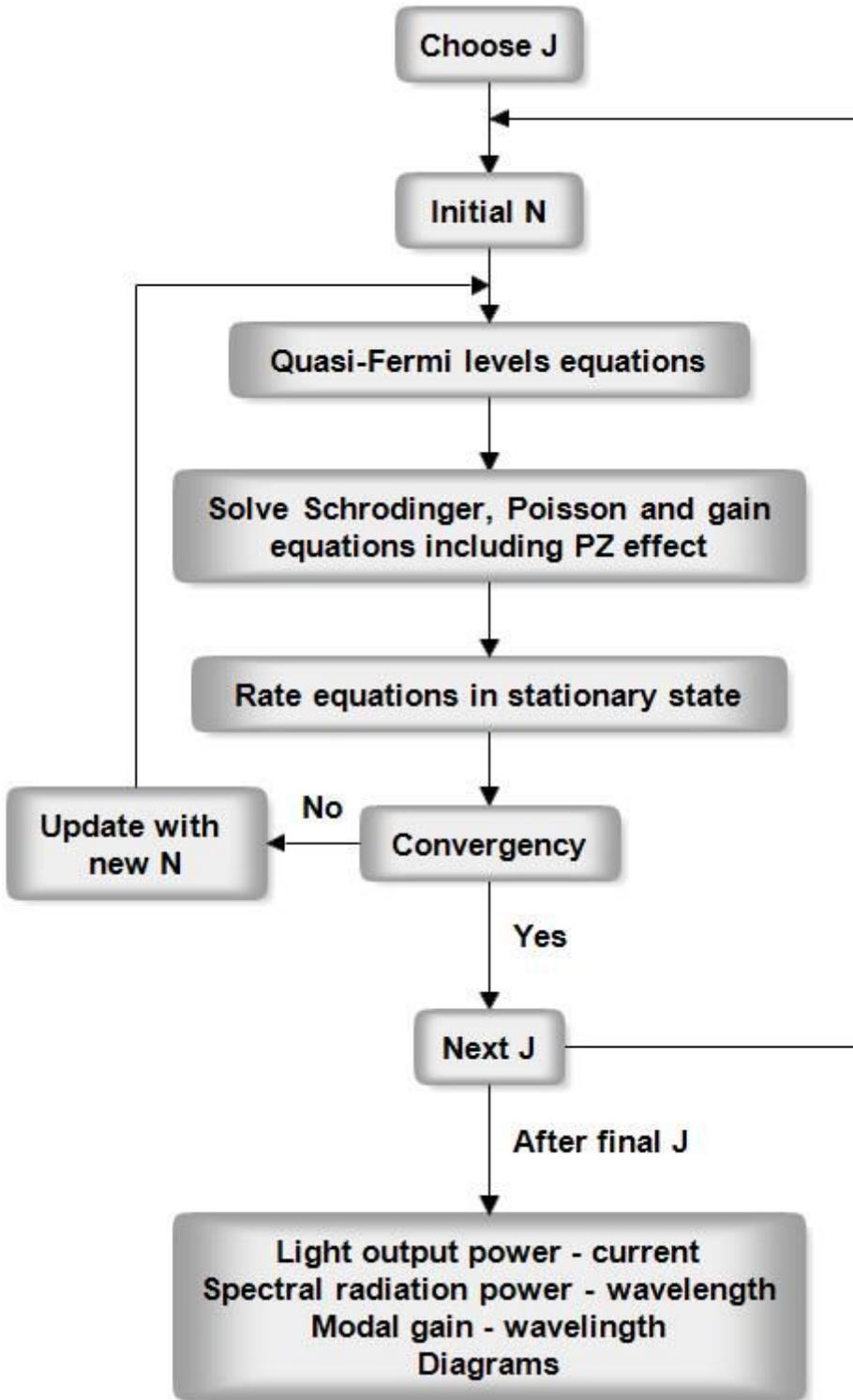


Figure 3

Flowchart of the process of the simulation method used in this study.

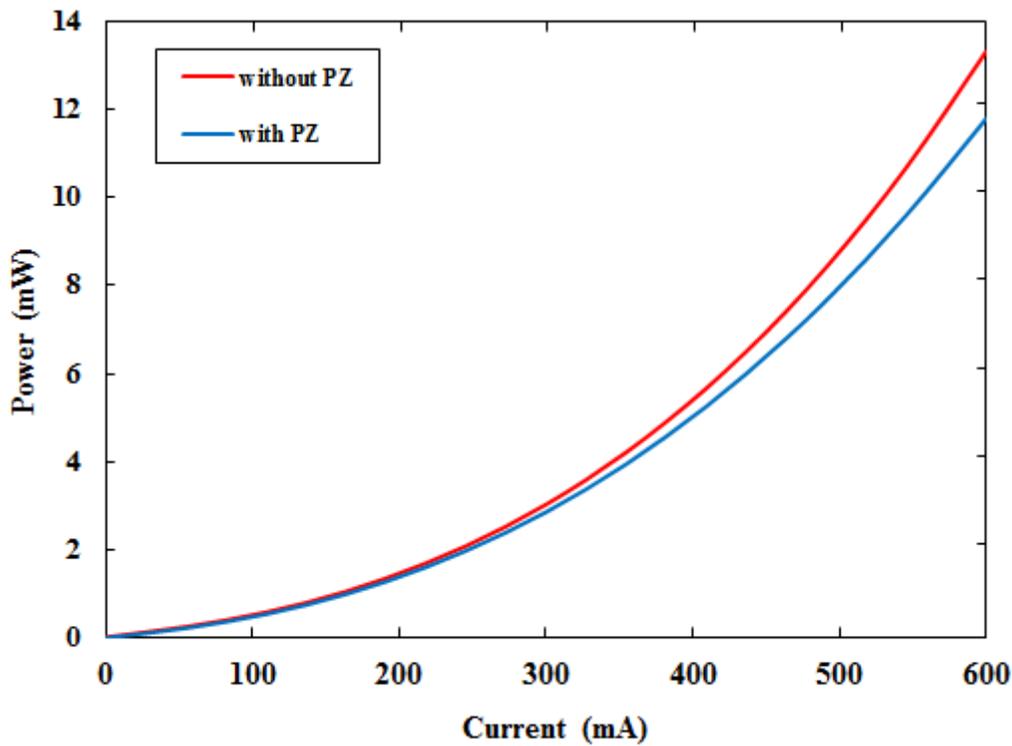


Figure 4

The light output power as a function of injection current.

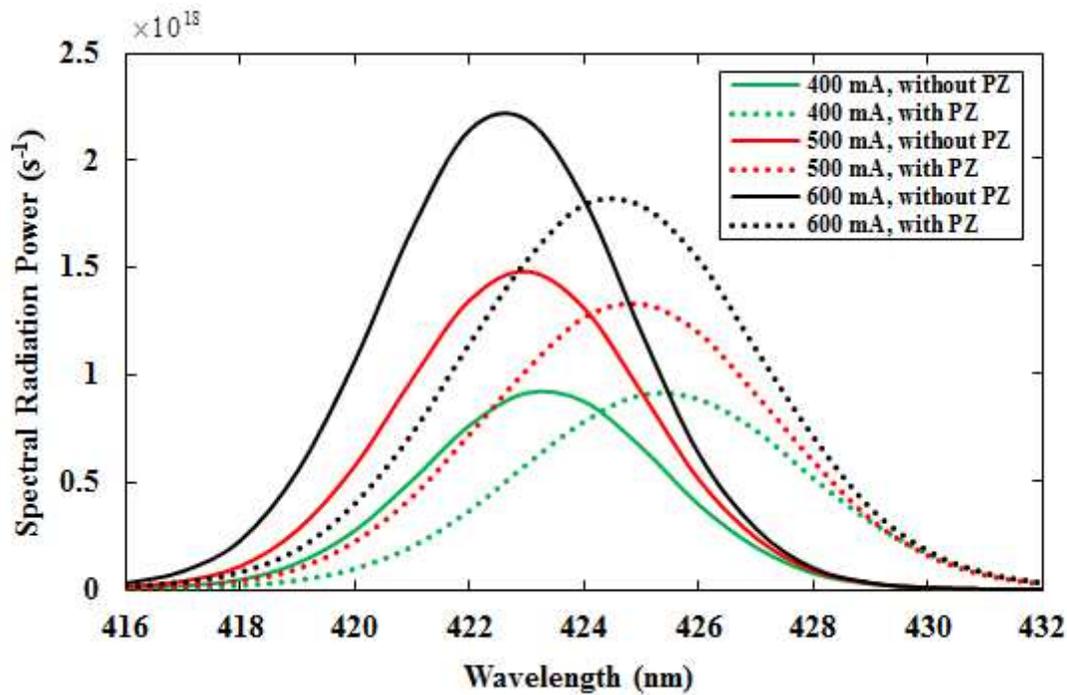


Figure 5

The spectral radiation power as a function of wavelength under different injection currents in without PZ field and with PZ field cases.

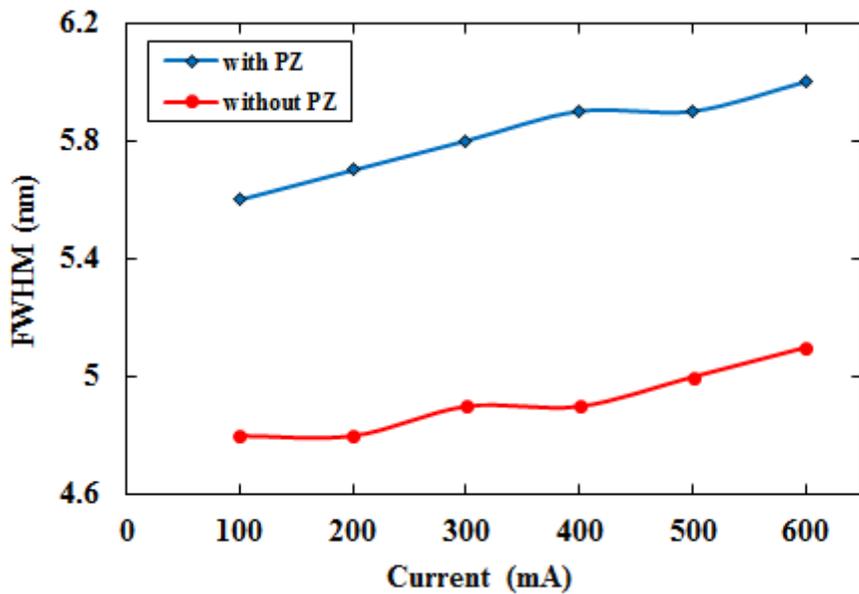


Figure 6

The FWHM of spectra as a function of injection current in without PZ field and with PZ field cases.

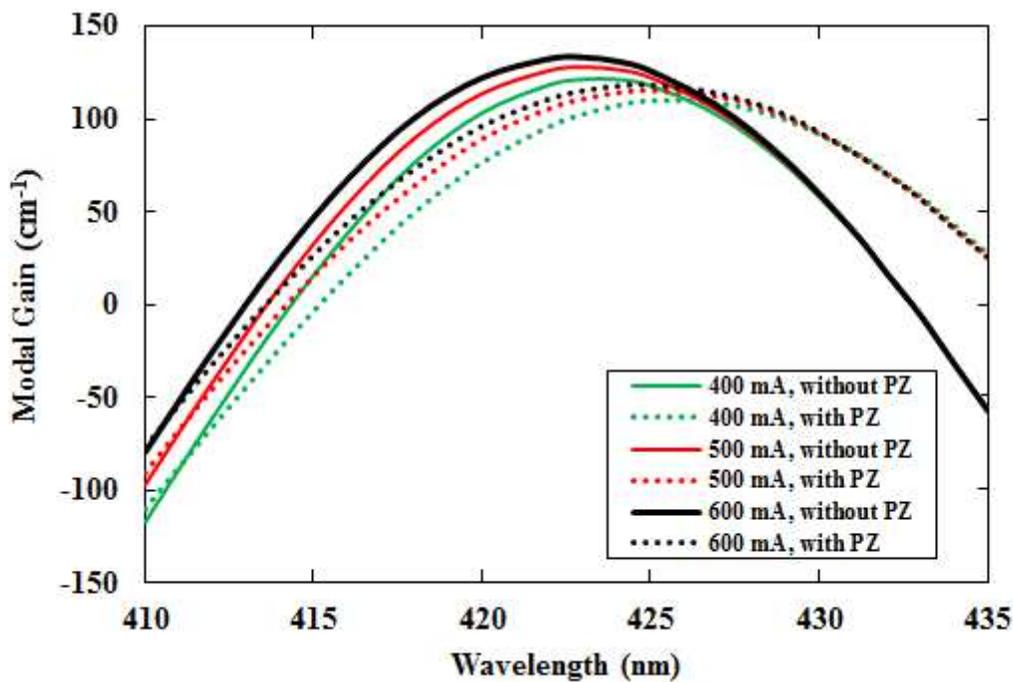


Figure 7

Modal gain as a function of wavelength at different injection currents in without PZ field and with PZ field cases.